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926-160

09/667,527

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MAKITA et al.

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U.S. PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS

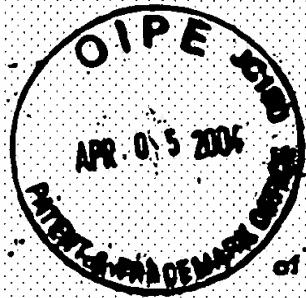
FOREIGN PATENT DOCUMENT						TRANSLATION	
DOCUMENT	DATE	COUNTRY	CLASS	SUBCLASS	YES	NO	
06-244103	9/1994	JP			Partial		

OTHER DOCUMENTS (including Author, Title, Date, Pertinent pages, etc.)

Other Documents (including Name, No, Date, etc., on page 1, etc.)	
*Examiner	Dr. <i>[Signature]</i> Date Considered <i>May - 2000</i>

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Form PTO-FB-A820 (Also PTO-1449)



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September 22, 2000

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U.S. PATENT DOCUMENTS

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TRANSLATION

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•Examiner

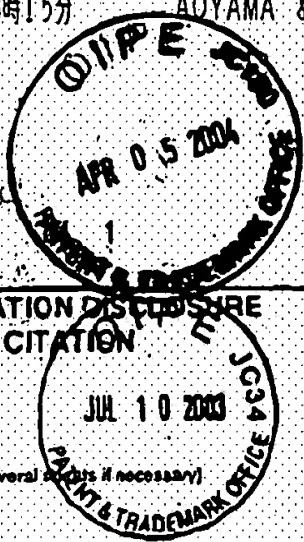
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OTHER DOCUMENTS (including Author, Title, Date, Pertinent pages, etc.)

Lee et al., "Fabrication of High-Mobility p-Channel Poly-Si Thin Film Transistors by Self-Aligned Metal-Induced Lateral Crystallization", *IEEE Electron Device Letters*, vol. 17, no. 8, August 1996, pp. 407-409

Bhal et al., "The Effects of MIC/MILC Interface on the Performance of MILC-TFTs", *Device Research Conf.*, 1998, pp. 110-111

Jin et al., "Performance of Thin-Film Transistors with Ultrathin Ni-MILC Polycrystalline Silicon Channel Layers", *IEEE Electron Device Letters*, vol. 20, no. 4, April 1999, pp. 167-169

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